

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/537,996	EICHLER, CHRISTIANNE	
Examiner	Art Unit	
Jiping Lu	3749	

SEARCHED				
Class	Subclass	Date	Examiner	
34	343,348 350,351 357,467 471,476	10/28/2007	JL	
	493,494			
	495			
134	1.3,21,32	10/28/2007	JL	
	36,37,42			
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INTERFERENCE SEARCHED					
·Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
•	DATE	EXMR		
INVENTOR NAME SEARCH	10/28/2007	JL		
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